

# DAY 1 | FEB 02

TIME

AGENDA | VENUE

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09:30 - 10:00	Registration (Participants split into two batches)   <b>C-CAMP Reception</b>
10:00 - 11:00	Introductory Talk   <b>TBD</b>
11:00 - 11:30	<b>Coffee/Tea Break and Networking</b>
11:30 - 12:30	Introduction to SU-8 Lithography   <b>Chausa</b>
12:30 - 13:30	<b>LUNCH BREAK</b>   <b>NCBS Canteen</b>
13:30 - 17:30	<ul style="list-style-type: none"><li>• Batch 1 - Soft Lithography   <b>NCBS Microfluidics Facility</b></li><li>• Batch 2 - SU-8 Lithography and Profilometry   <b>NCBS Microfluidics Facility</b></li></ul>

## DAY 2 | FEB 03

TIME	AGENDA   VENUE
09:00 - 13:00	<ul style="list-style-type: none"><li>• Batch 2 - Soft Lithography   <b>NCBS Microfluidics Facility</b></li><li>• Batch 1 - SU-8 Lithography and Profilometry   <b>NCBS Microfluidics Facility</b></li></ul>
13:00 - 13:45	<b>LUNCH BREAK   NCBS Canteen</b>
13:45 - 16:30	Micromachining for Microfluidic Devices   <b>MedTech Microfabrication Facility, C-CAMP</b>
16:30 - 17:00	<b>COFFEE/TEA BREAK</b>
17:00 - 18:00	Feedback, Closing Remarks and Certificate Distribution   <b>Chausa</b>